

## Print

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☐ 3. Document ID: US 5963800 A

L4: Entry 3 of 7

File: USPT

US-PAT-NO: 5963800

DOCUMENT-IDENTIFIER: US 5963800 A

TITLE: CMOS integration process having vertical channel

DATE-ISSUED: October 5, 1999

## INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Augusto; Carlos Jorge Ramiro Proenca	Louvain			BE

US-CL-CURRENT: 438/212; 257/334, 438/213, 438/270, 438/277, 438/279, 438/283

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments	KWIC
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☐ 4. Document ID: US 5920088 A

L4: Entry 4 of 7

File: USPT

US-PAT-NO: 5920088

DOCUMENT-IDENTIFIER: US 5920088 A

TITLE: Vertical MISFET devices

DATE-ISSUED: July 6, 1999

## INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Augusto; Carlos Jorge Ramiro Proenca	Leuven			BE

US-CL-CURRENT: 257/192; 257/194, 257/330

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments	KWIC
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☐ 5. Document ID: US 5914504 A

L4: Entry 5 of 7

File: USPT

US-PAT-NO: 5914504

DOCUMENT-IDENTIFIER: US 5914504 A

TITLE: DRAM applications using vertical MISFET devices

DATE-ISSUED: June 22, 1999

## INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Augusto; Carlos Jorge Ramiro Proenca	Leuven			BE

US-CL-CURRENT: 257/192; 257/195, 257/200, 257/201, 257/301, 257/306

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments
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KIMC

☐ 6. Document ID: US 5510628 A

L4: Entry 6 of 7

File: USPT

US-PAT-NO: 5510628

DOCUMENT-IDENTIFIER: US 5510628 A

TITLE: Deep ultraviolet photolithographically defined ultra-thin films for selective cell adhesion and outgrowth and method of manufacturing the same and devices containing the same

DATE-ISSUED: April 23, 1996

## INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Georger, Jr.; Jacque H.	Springfield	VA		
Stenger; David A.	Reston	VA		
Fare; Thomas L.	Washington	DC		

US-CL-CURRENT: 257/32; 257/37, 427/98

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments
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KIMC

☐ 7. Document ID: US 5324591 A

L4: Entry 7 of 7

File: USPT

US-PAT-NO: 5324591

DOCUMENT-IDENTIFIER: US 5324591 A

TITLE: Deep ultraviolet photolithographically defined ultra-thin films for selective cell adhesion and outgrowth and method of manufacturing the same and devices containing the same

DATE-ISSUED: June 28, 1994

## INVENTOR-INFORMATION:

NAME	CITY	STATE	ZIP CODE	COUNTRY
Georger, Jr.; Jacque H.	Springfield	VA		
Stenger; David A.	Reston	VA		
Fare; Thomas L.	Washington	DC		

US-CL-CURRENT: 428/552; 428/336, 430/296, 438/1

Full	Title	Citation	Front	Review	Classification	Date	Reference	Sequences	Attachments
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(1 AND ADHESION).USPT,PGPB,JPAB,EPAB,DWPI,TDBD.	7
(L1 AND "ADHESION").USPT,PGPB,JPAB,EPAB,DWPI,TDBD.	7

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